OIPE IAP2
JUN 13 2007
PATENT & TRADEMARK OFFICE

Attorney Docket No. 0756-7210

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 1725
Hirotada OISHI	)	Examiner: Samuel M. Heinrich
Serial No. 10/684,416	)	
Filed: October 15, 2003	)	
For: LASER IRRADIATION APPARATUS AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE BY USING THE LASER IRRADIATION APPARATUS	)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 11, 2007.

Adele M Stamper

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.